

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

|                               |   |                         |
|-------------------------------|---|-------------------------|
| In re Application of:         | ) |                         |
|                               | ) |                         |
| Goro NAKATANI et al.          | ) | Confirmation No.: 4701  |
|                               | ) |                         |
| Application No.: 10/043,276   | ) | Group Art Unit: 2811    |
|                               | ) |                         |
| Filed: January 14, 2002       | ) | Examiner: Junghwa M. Im |
|                               | ) |                         |
| For: SEMICONDUCTOR DEVICE AND | ) | <b>Mail Stop RCE</b>    |
| METHOD FOR MANUFACTURING      | ) |                         |
| THE SAME                      | ) |                         |

**Mail Stop RCE**

Commissioner of Patents  
U.S. Patent and Trademark Office  
Alexandria, VA 22314

Sir:

**AMENDMENT WITH RCE**

Prior to the continued examination of the above-identified application, please amend the application as follows: